

Geant4 Simulation (for FP420)

[in OSCAR(CMS) framework]

items:

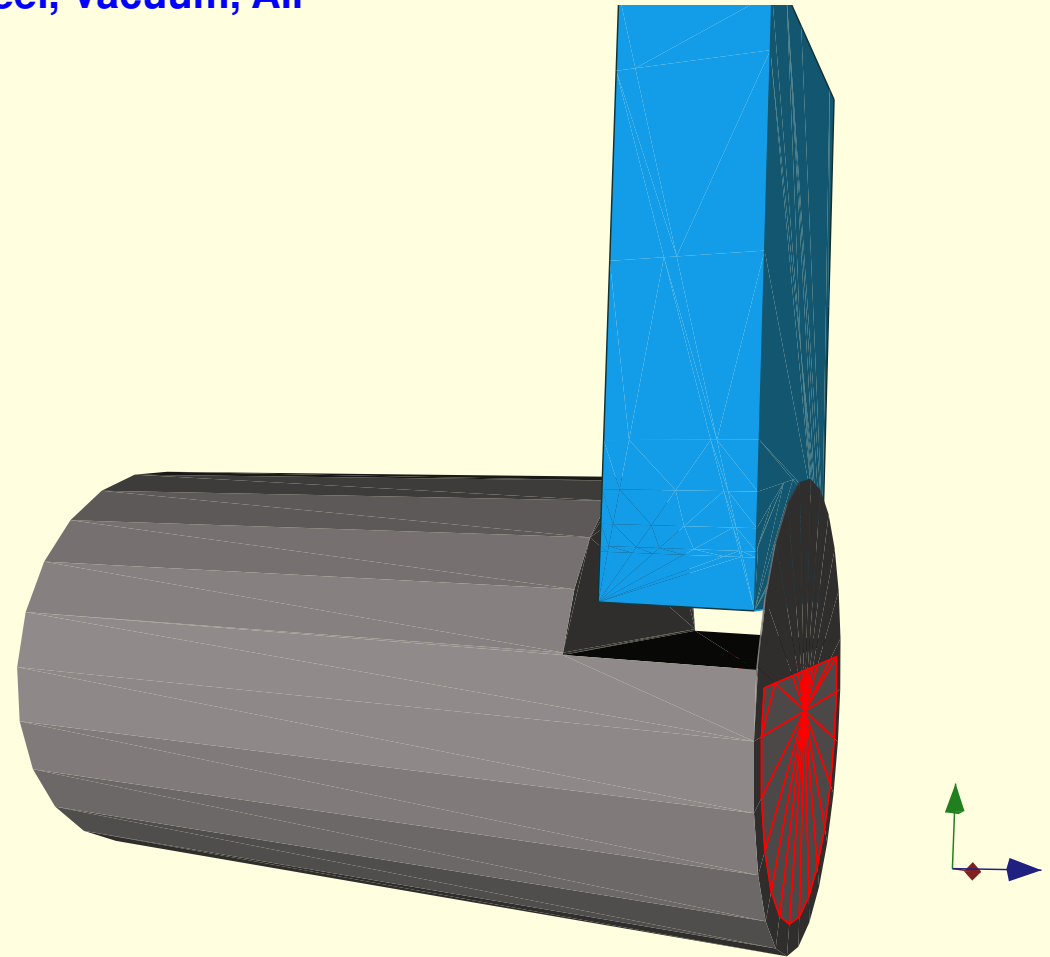
- geometry description (\Rightarrow xml)
- multiple interactions (**MI**)
- multiple scattering (**MSC**)
- summary

Pocket geometry

- subtraction Solid combine Tubs and Box solids
- materials: Stainless Steel, Vacuum, Air

- beam pipe (bp) radius: 40 mm
- bp unit length (bpul) : 2.8 m
- bp wall thickness (bpt) : 5 mm
- bp pocket y-thickness (bppyt) : 3.5 mm
- pocket z-size: 30 mm
- y pocket shift: 10 mm
- y-gap(pocket - station): 2 mm
- window thickness (wt) : 0.25 mm

The configuration unit to be used for full geometry set up (with 3, 5, ...stations)



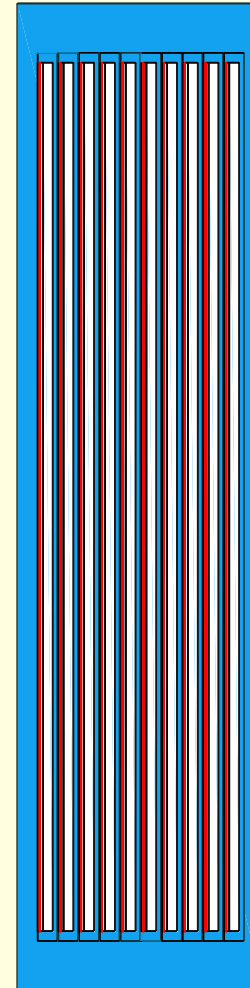
Station geometry

- few Planes (up to 10) per Station

- materials: Silicon, Boron Polyethylene., Ceramic, Air,

- Station dimensions: $84 \times 100 \times 25 \text{ mm}^3$
- 1-st layer Si thickness: 0.200 mm
- bumpbouding thickness: 0.020 mm
- 2-nd layer Si thickness: 0.300 mm
- Ceramic thickness (ct) : 1.00 mm
- 2-layer-Si Plane dimensions: $80 \times 98 \times 2 \text{ mm}^3$
- Distance between centers of Planes: 2.5 mm
- Parameters in black brackets were varied in simulation studies

- One can generate events with interactions in the detector
- Analysis at aStep, EndOfTrack, EndOfEvent:



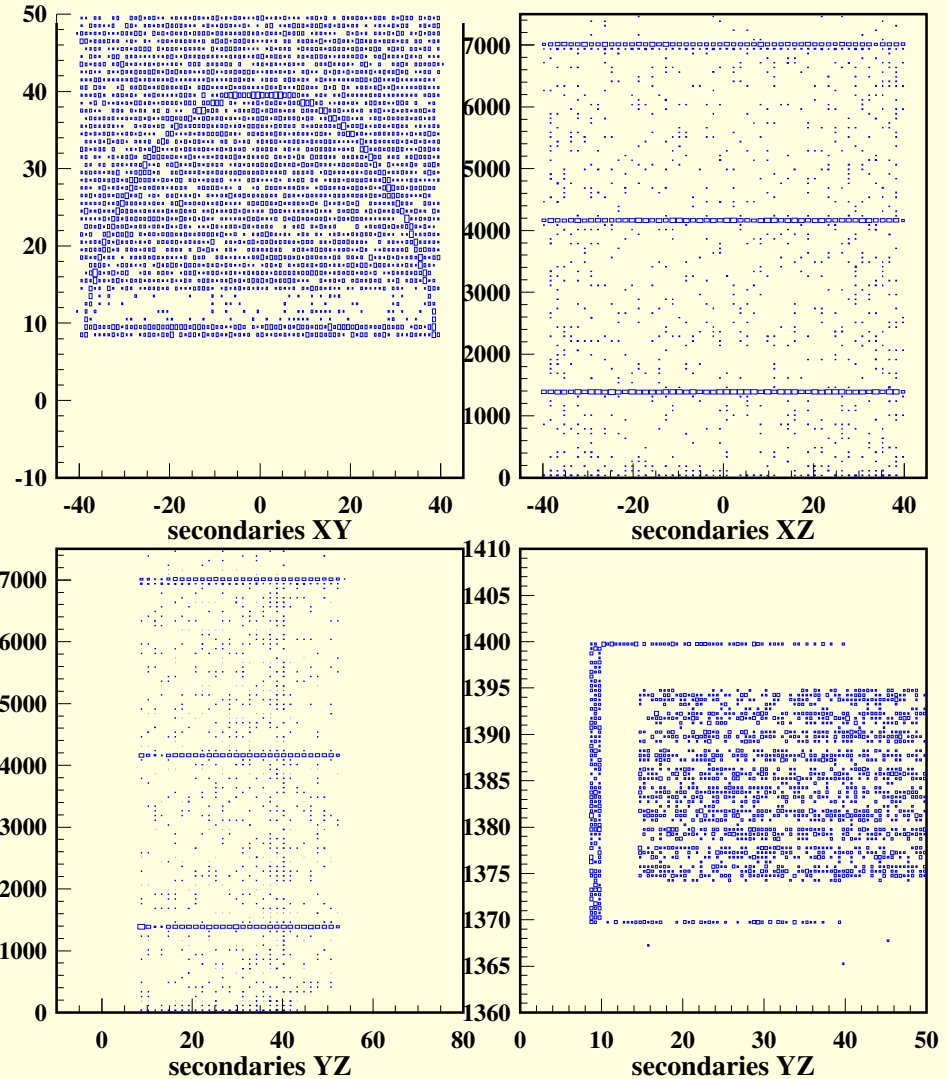
Scan with protons

★ point of origin with 3 Stations



- eta: $(8.8 \div 11.4) \simeq (\tan(\theta): 120./420000. \div 10./420000.)$
- phi: $0 \div 2\pi$
- Vertex: $(-40. \div +40., +8. \div +50., 0.)$ mm
- $P_p = 70$ GeV , 50000 ev.
- to check the details of geometry:
 put $b_{pt} = 0.1$ mm, $b_{pyt} = 1.5$ mm
 to avoid too large μ MI , $w_t = 0.5$ mm

Starting points of secondaries



Define the sign of **!MI**:

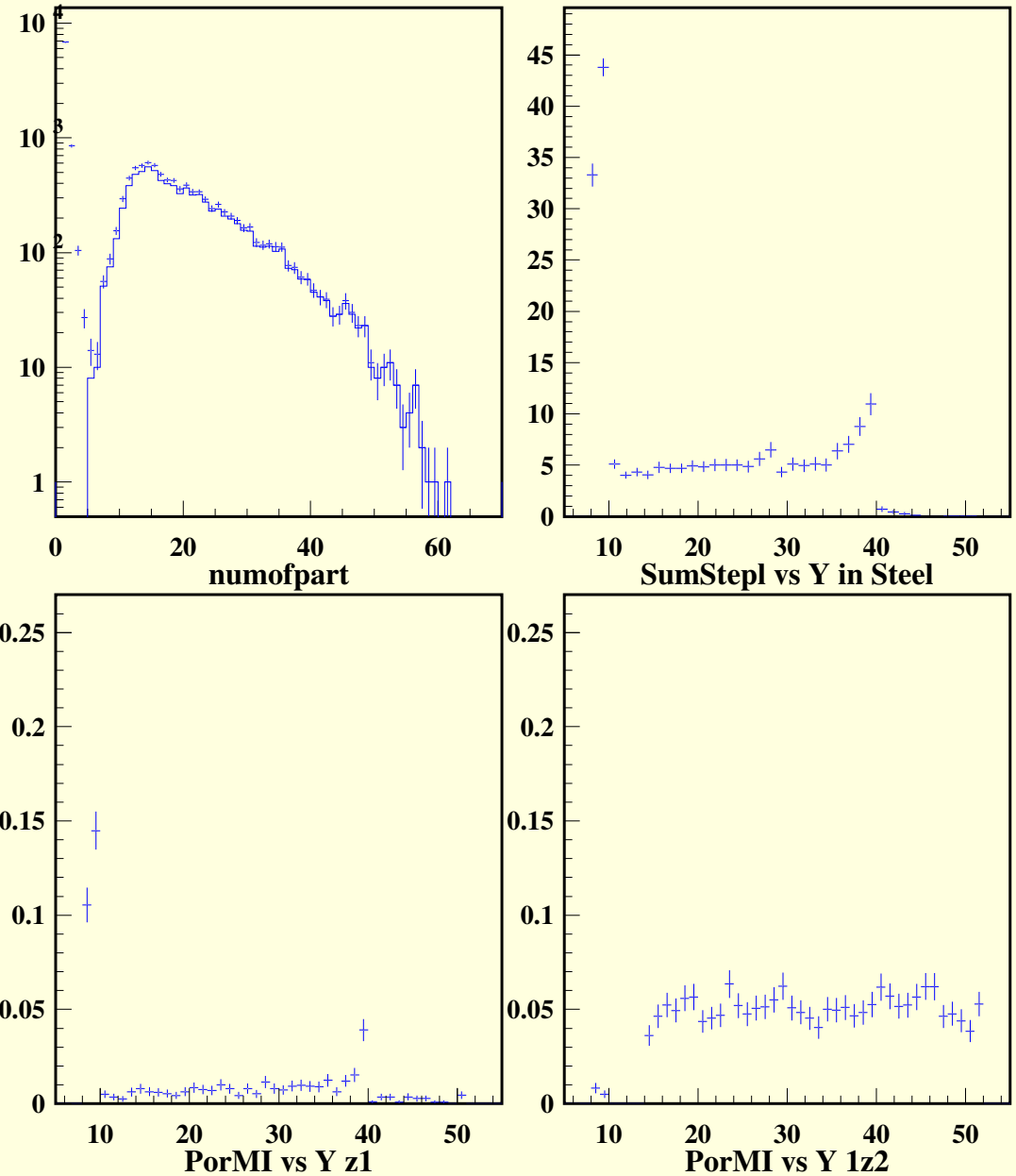
$$Z_{prim.track\ lastpoint} > Z_{III-rdStation\ position}$$

MI in proton scan

(still 70 GeV protons)

- check w/ number of secondary particles:
⇒ strong correlation(histogram) w/ cut:
 $Z_{lastpoint}^{prim.track} < Z_{III-rdStation}$
- portion of MI vs. Y-vtx at $Z_{infront}^{I-stStation}$ and z range of I-st Station \iff track length in St.Steel vs. Y-vtx

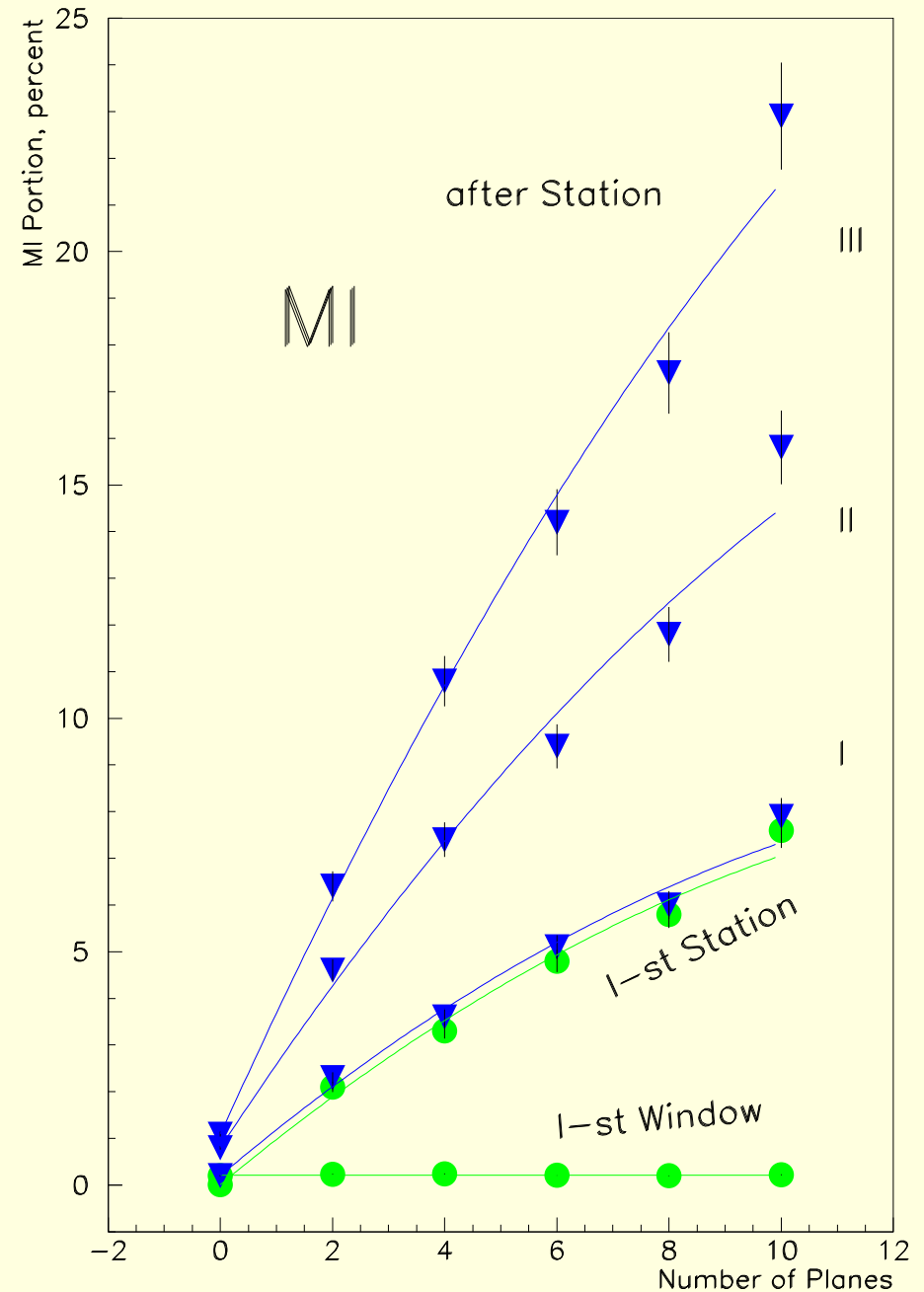
start real job with
 $P_p = 7$ TeV,
vertex(0.,20.,0.),
2500 ev. / point,
wt = 0.25 mm,
bpt = 0.01 mm,
bppyt = 3.5 mm



MI as function of n Planes

- strong rise vs. n Planes
- portion of MI w/ 10 Planes is $\simeq 20\%$
- portion of MI w/ 6 Planes is $\simeq 15\%$
- contribution of $250\ \mu\text{m}$ St.Steel Window is negligible ($\sim 0.2\%$)

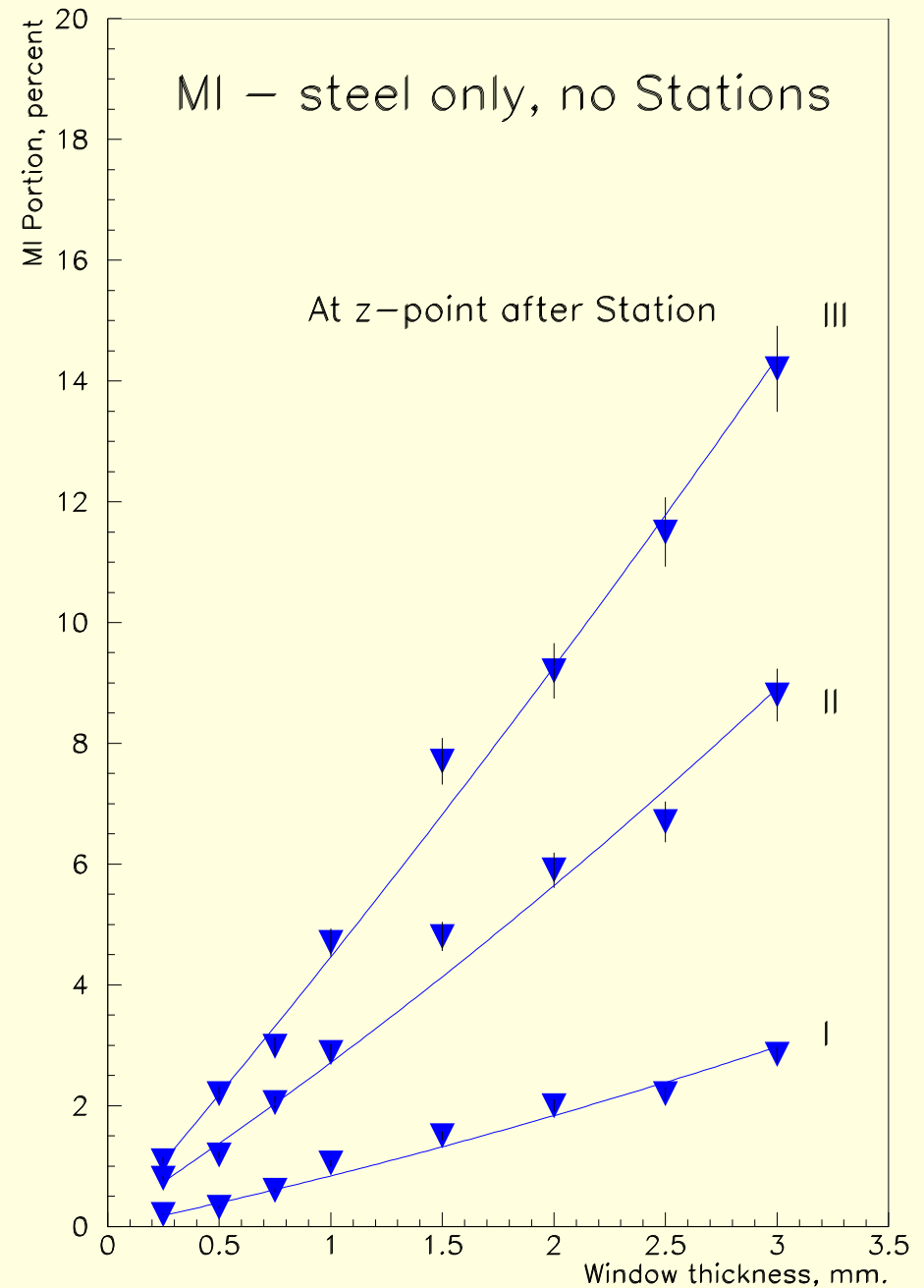
check last statement ...



MI as function of wt

- strong rise vs. *wt*
- contribution of $250\ \mu\text{m}$ *wt* to MI is $\simeq 1.2\%$
- contribution of $1\ \text{mm}$ *wt* to MI is $\simeq 4\%$

check MI contribution
for Ceramic ...



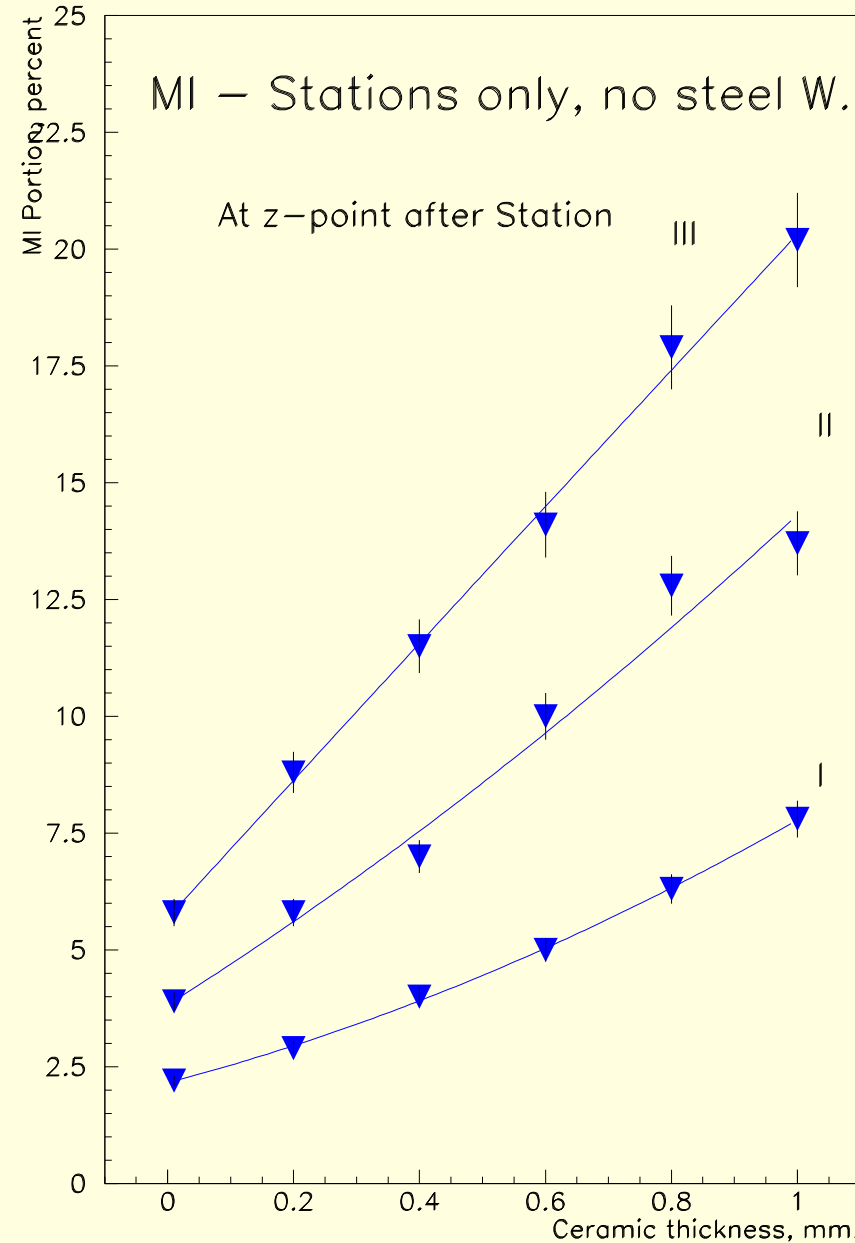
MI as function of ct

(1 mm ct is foreseen as default)

- strong rise vs. ct
- at $10\mu m$ ct there is just Silicon contribution to MI $\implies \leq 6\%$
- pure Ceramic contribution of 1mm thickness $\sim 15\%$
(reminder: w/ 10 Planes and 3 Stations, overall Ceramic thickness is 3 cm)

One can do estimation of MI portion for different number of Planes and ct keeping fixed the number of Stations = 3 and $wt=250\mu m$

(10 Planes per Station)



Estimation of MI portions(%) with 3 Stations

ct, mm	2 Planes	4 Planes	6 Planes	10 Planes
0.4	4.4	6.7	9.1	11.5
0.6	5.2	8.2	11.2	14.5
0.8	6.0	9.6	13.3	17.5
1.0	6.5	10.5	14.5	20.5

- example of calculation for 4 Planes and $ct=0.6 mm$:

$$14.5\% * ((10.5-1.2)\% / (20.5-1.2)\%) + 1.2\% = 8.2 \%$$

$$(14.5\% * ((10.5-1.2)\% / (20.5-1.2)\%) + 4.0\% = 11.0 \% \leftarrow wt=1mm)$$

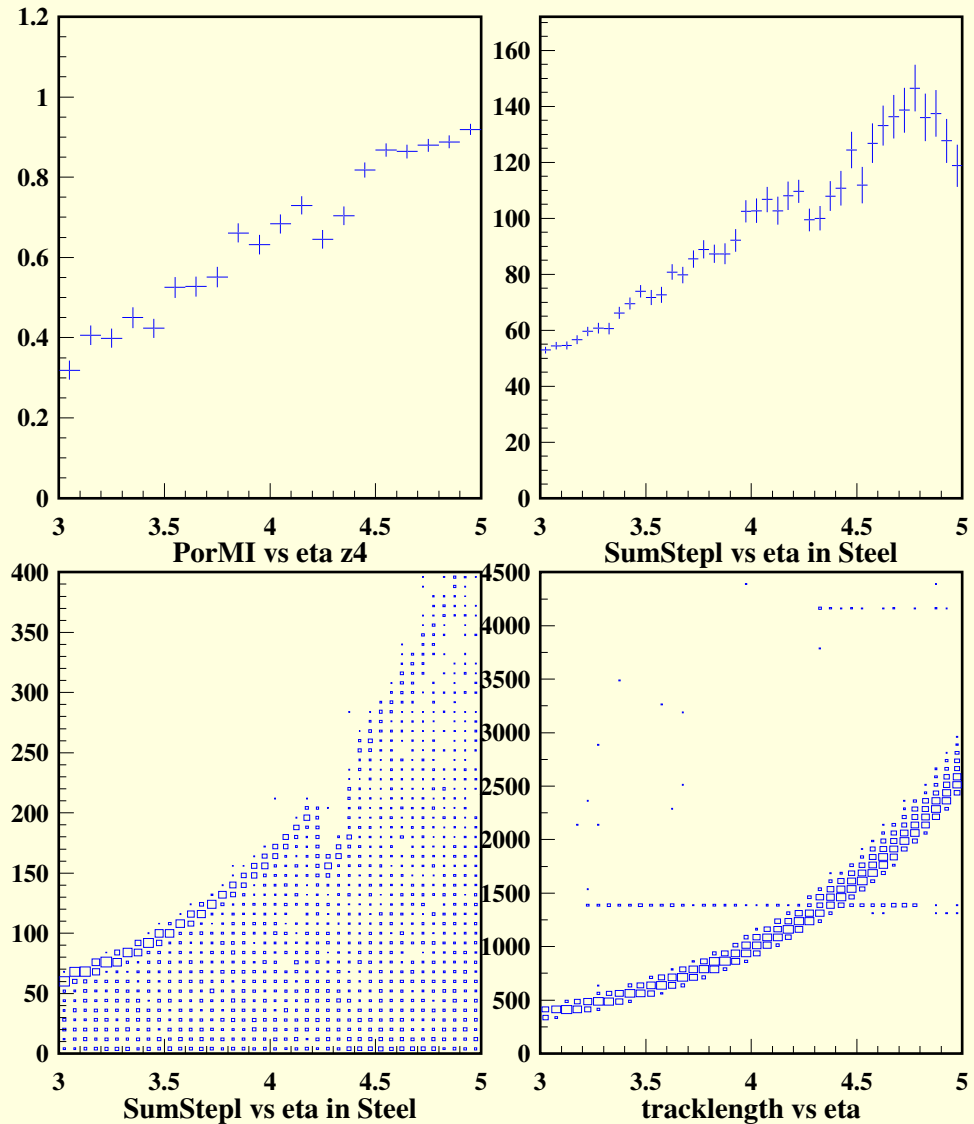
Reminder: each plane include 2 Si layes (0.3 + 0.2 mm)

Exercise with protons going through steel

realistic (bpt) & (bpyt): 6 mm and 3.5 mm accordingly

- eta: (3. ÷ 5.) \simeq (tan(θ): 120./1400. ÷ 10./1400.), phi: π
- Vertex: (0., 0., 0.) mm, $P_p = 70$ GeV , 10000 ev.

~ 65 % of MI for l-st
Station position



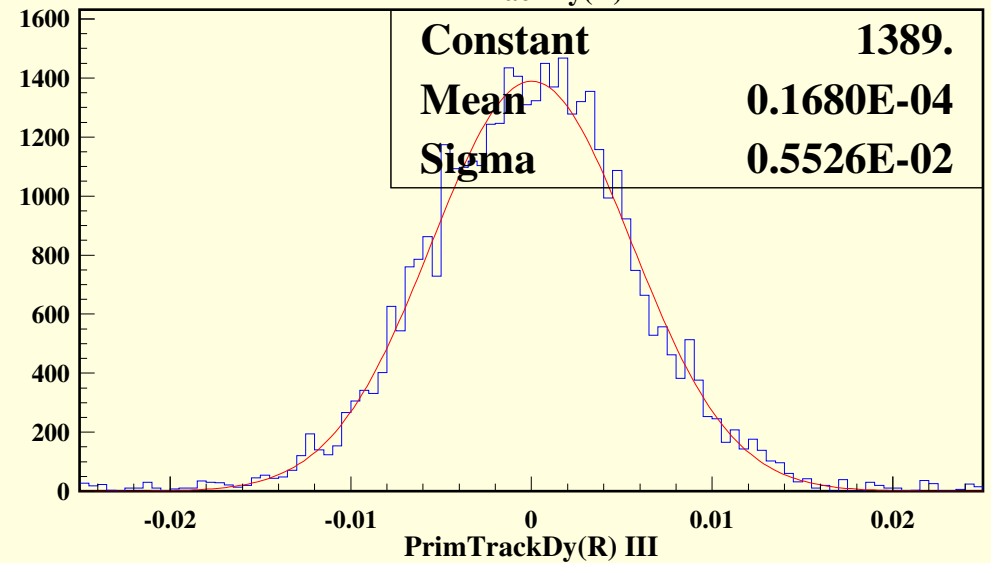
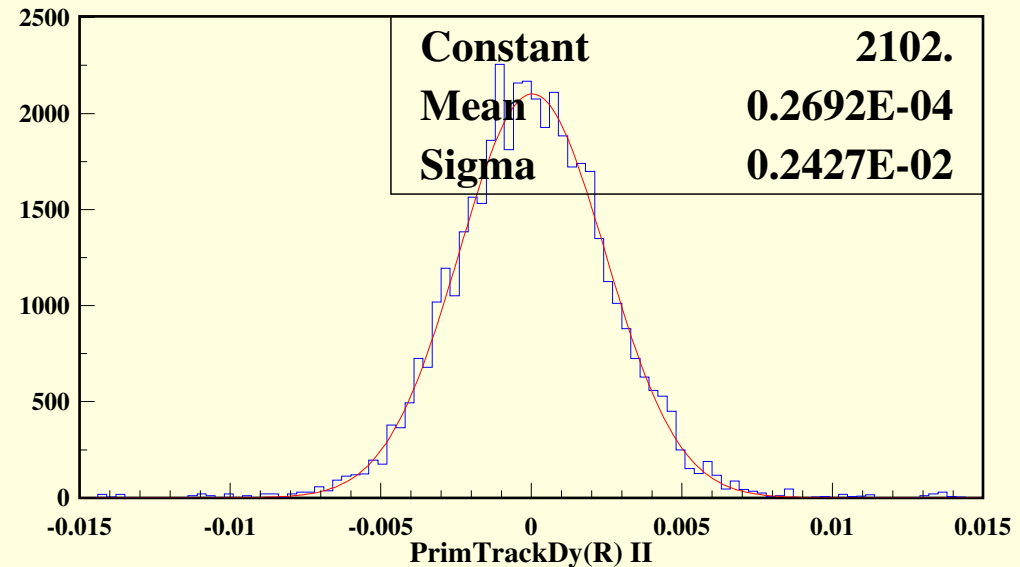
Effect of MSC

10(6) Planes

- eta: (8.8 ÷ 11.4), phi: 0 ÷ 2 π,
vertex(0.,20.,0.), P_p = 7 TeV, 5000 ev.,
distance between I-st and last Station
2·bpul = 5.6 m
- Plots:
Y(X) - deviation of track from primary direction at z of Si plates(last step inside every Si media) for II-nd and III-rd Stations
- For I-st Station: $\sigma_{deviation} \sim 0.001 \mu m$
For II-nd Station: $\sigma_d \sim 2.4(2.0) \mu m$
For III-rd Station: $\sigma_d \sim 5.5(4.5) \mu m$
- Corresponding deviations for 2·bpul = 8.0 m:
 $\sigma_{II} = 3.6(2.8)\mu m$, $\sigma_{III} = 7.9(6.3)\mu m$
(Using hits: $\sigma_{II} = 3.8\mu m$, $\sigma_{III} = 8.5\mu m$)

estimation of \perp uncertainty
of IP position:
 $\sigma \sim 150(125) \mu m$

$$(Z/z) * \sqrt{(\Sigma(D_i)/n)}$$



Summary

- The version of G4-simulation of FP420 is prepared (pure simulation: no digitization & reconstruction).
- The study of **MI** effects for different geometry parameters was presented.
- The influence of **MSC** on position resolution was estimated.
- The things to do:
- short term - simulation:

- implementation of more realistic geometry set up, materials, rotation matrices

- NumberingScheme, production cuts

- SensitiveDetector: class of SimHitsCollection \implies studies with hits

SimHitsCollection provide input information for signal simulation



- long term - provide digitization & reconstruction to have complete MC:

- charge collection:

- SimHitsCollection: entrance and exit points, E_{dep}

- divide track segment into 10 μm long sub-segments.

- take into account Landau fluctuations in thin material layers:
assign a fraction of energy for each sub-segment.

- drift in magnetic field (Lorentz angle)

- charge collected by every strip, a list of hit strips

- add the noise contribution

- convert the charge into an integer number(ADC digitization)

- strip zero suppression

- cluster(set of adjacent strips) finding algorithm

- precise hit position reconstruction

- track reconstruction